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	Application No.	Applicant(s)	V4V
Notice of Allowability	10/004,714	MEIKLE ET AL.	
	Examiner	Art Unit	
	Ginette Peralta	2814	<u> </u>
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSE i) or other appropriate con RIGHTS. This application	D in this application. If not inclunmunication will be mailed in du	ded e course. <b>THIS</b>
<ol> <li>This communication is responsive to Response filed on 9.</li> <li>The allowed claim(s) is/are 38-74.</li> <li>The drawings filed on 05 December 2001 are accepted by 4. Acknowledgment is made of a claim for foreign priority un a) All b) Some* c) None of the:         <ol> <li>Certified copies of the priority documents hav 2. Certified copies of the priority documents hav 3. Copies of the certified copies of the priority documents hav</li> </ol> </li> </ol>	y the Examiner. Ider 35 U.S.C. § 119(a)-(d le been received. Ie been received in Applic	ation No	cation from the
International Bureau (PCT Rule 17.2(a)).  * Certified copies not received:  5. Acknowledgment is made of a claim for domestic priority to (a) The translation of the foreign language provisional of the foreign l	application has been rece under 35 U.S.C. §§ 120 a of this communication to fi	ived. nd/or 121. le a reply complying with the rec	
7. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which gives rea			NOTICE OF
8. CORRECTED DRAWINGS must be submitted.  (a) including changes required by the Notice of Draftspe  1) hereto or 2) to Paper No.  (b) including changes required by the proposed drawing  (c) including changes required by the attached Examine  Identifying indicia such as the application number (see 37 CFR each sheet.	correction filed, \ r's Amendment / Comme	which has been approved by the nt or in the Office action of Pape	er No
9. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT FOR			. Note the
Attachment(s)			
<ul> <li>Notice of References Cited (PTO-892)</li> <li>Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>Information Disclosure Statements (PTO-1449), Paper No</li> <li>Examiner's Comment Regarding Requirement for Deposit of Biological Material</li> </ul>	4☐ Inter 6⊠ Exar 8⊠ Exar 9⊡ Othe	ce of Informal Patent Application view Summary (PTO-413), Pape niner's Amendment/Comment niner's Statement of Reasons for	er No
	SU. Lan	ار در	.,}

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## **EXAMINER'S AMENDMENT**

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Marvin Beekman on 10/6/03.

The application has been amended as follows:

In claim 1, line 4, change "nitride" to -- nitrogen --.

2. The following is an examiner's statement of reasons for allowance:

The primary reason for the allowance of the claims is the inclusion of the feature of an integrated circuit comprising an electrode formed of chemically vapor deposited tungsten nitride wherein the tungsten nitride includes silicon and is formed using a gas comprising nitrogen, tungsten and silicon which is not anticipated nor rendered obvious over the prior art of record. It has been disclosed by the applicant that the addition of silane or other silicon-based gas reduces encroachment into any silicon based materials exposed to the tungsten nitride, improves adhesion of the tungsten nitride to its underlying layer, and reduces the bulk resistivity of the tungsten nitride (page 7 lines 1-5). Thus, the addition of the silicon-based gas directly affects the deposited layer and differentiates it from other devices.

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ginette Peralta whose telephone number is (703) 305-7722. The examiner can normally be reached on Monday to Friday 8:00 AM- 5:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael Fahmy can be reached on (703) 308-4918. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.